



DK-US045031

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Toshio TANAKA et al.
Serial No.: 10/774,690
Filed: February 10, 2004
For: PLASMA REACTOR AND
PURIFICATION EQUIPMENT

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents
Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicants bring the attached references to the Examiner's attention and request that they be considered and made of record in this application. Also attached is a completed PTO-1449 form. This Information Disclosure Statement is being filed within three (3) months of the filing date of this application. Thus, ***no fee is believed to be due for this Information Disclosure Statement.*** However, the Commissioner is authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

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Prompt examination on the merits is respectfully requested.

Respectfully submitted,

David L. Tarnoff
Reg. No. 32,383

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